

Electronic Acknowledgement Receipt

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Application Number:	10577175
International Application Number:	
Confirmation Number:	3451
Title of Invention:	Method for Self-Supported Transfer of a Fine Layer by Pulsation after Implantation or Co-Implantation
First Named Inventor/Applicant Name:	Nguyet-Phuong Nguyen
Customer Number:	90678
Filer:	Jasper W. Dockrey/Nkosi Harvey
Filer Authorized By:	Jasper W. Dockrey
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Application Type:	U.S. National Stage under 35 USC 371

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Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1	NPL Documents	Aspar_et_al_1996_99-111.pdf	386796 e8dc61f8d5b60098831bb24f429b77aff092419e	no	7

Warnings:

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2	NPL Documents	Aspar_et_al_1996_1985-1986.pdf	80682	no	2
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3	NPL Documents	Aspar_et_al_1997_233-240.pdf	440138	no	8
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7	NPL Documents	Auberton-Herve_A_J_et_al_SOI_Materials_for_ULSI_Applications.pdf	594763	no	5
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9	NPL Documents	Blanchard-Lagahae-C-Hydrogen-and-Helium.pdf	584601	no	13
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20	NPL Documents	Carter_G_et_al_The_Collection_of_Ions_Implanted_in_Semiconductors_II.pdf	669972	no	8
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39	NPL Documents	Duo_et_al_2001_3780-3786. PDF	549396 0e37d771df074bcd56fba107f0f36ae063f281a	no	6
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40	NPL Documents	DiCioccio_et_al_1997.pdf	744238 17d4fa7861fa5bb6dc632f8e6bda18cb494b090c	no	8
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Information:					
Total Files Size (in bytes):			24467800		
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